

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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ညှှော်ပြုငation Serial No	
	8492
Filing Date	June 13, 2001
Inventor	Kie Y. Ahn, et al
Assignee	Micron Technology, Inc.
Group Art Unit	2814
Examiner	T. Le
Attorney's Docket No	Ml22-1534
Customer No	
Title: A Dielectric Layer Forming Method:	and Devices Formed Therewith

e: A Dielectric Layer Forming Method and Devices Formed Therewith

## PRELIMINARY AMENDMENT TO ACCOMPANY AN RCE FILING

To:

**Box RCE** 

**Commissioner for Patents** 

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## **AMENDMENTS**

No amendments.